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121503  
U.S. PTO  
10/736007

Docket No. 8034 USA L/W-C/W-C/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

19270 U.S. PTO  
10/736007  
121503

Re: Inventor(s): Steven Verhaverbeke, Christopher Laurent Beaudry  
Title: SINGLE WAFER CLEANING METHOD TO REDUCE PARTICLE DEFECTS ON A WAFER SURFACE

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 30 pages.  
☒ Drawings totaling 6 pages,    Formal ☒ Informal.  
☒ Executed Declaration and Power of Attorney.  
☒ Assignment of the invention to Applied Materials, Inc.  
☒ Assignment Recordation Cover Sheet  
☒ Information Disclosure Statement and copy of cited reference.

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	62	- 20 =	42	X \$18.00	756.00
Independent Claims	6	- 3 =	3	X \$86.00	258.00
Basic Filing Fee				\$770.00	\$770.00
Recording each patent assignment per property				\$40.00	\$40.00
TOTAL FEES					\$1824.00

- ☒ The Commissioner is hereby authorized to charge \$1824.00 to Deposit Account No. 50-1074.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:
- PATENT COUNSEL  
APPLIED MATERIALS, INC.  
Legal Affairs Department  
P.O.BOX 450A  
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EV 409362405 US

Date of Deposit 12-15-03

Signature [Signature]

Respectfully submitted,

[Signature]

Robert W. Mulcahy  
Registration No. 25,436